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): Anderson et al.	NSMISSION BY FAC	SIMILE (37 CFR 1.8)	Docket No. BUR920030098US1
	olion No. 95,9 0 \$	Filing Date 11/5/2003	Examiner Nadav, Ori	Group Art Uni 2811
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	tify that this		Restriction Election (2 pages) (Identify type of correspondence)	
		ine United States Patent a	and Trademark Office (Fax. No.	703-872-9306
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Docket No. BUR920030098US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Anderson et al.

Group Art Unit: 2811

Filed: 11/5/2003

Examiner: Naday, Ori

Serial No.: 10/605,905

Title: METHOD OF FABRICATING A FINFET

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

RESTRICTION ELECTION

In response to the Restriction Requirement dated February 1, 2005, Applicants hereby provisionally elect Group II, claims 1-21, drawn to a process of making a semiconductor device, Class 438, subclass 22. This election is made with traverse, and Applicants hereby reserve the right to file a divisional application in connection with unelected claims 22-28, drawn to a semiconductor device.

With regard to the Restriction Requirement, Applicants respectfully submit that the subject matter of all claims 1-28 is sufficiently related that a thorough search for the subject matter of any one group of claims would encompass a search for the subject matter of the remaining claims. Thus, Applicants respectfully submit that the search and the examination of the entire application could be made without serious burden. See MPEP § 803, in which it is stated

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that "if the search and examination of the entire application can be made without serious burden, the Examiner must examine it on the merits." Applicants respectfully submit that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicants and duplicative examination by the Patent Office.

Should the Examiner require or request anything further from Applicants prior to examination, the Examiner is requested to contact Applicants' undersigned representative at the telephone number below. Otherwise, Applicants request early and favorable examination on the merits.

Date: 2/10/2005

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